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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): M. MASUDA et al
Serial No.: 10/743,882
Filed: December 24, 2003
For: A SEMICONDUCTOR DEVICE AND A METHOD OF
MANUFACTURE
Group: 2815
Examiner: S. CLARK

AMENDMENT

MS: AMENDMENT

Commissioner For Patents
POB 1450
Alexandria, VA 22313-1450

December 22, 2004

Sir:

In response to the outstanding Office Action, dated September 22, 2004,
please amend the above-identified application as listed below and as set forth on
the following pages:

Amendments to the Claims.

Remarks are included following the Amendments.

12/23/2004 NNGUYEN1 00000076 10743882

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